Application Number:	100	10636021					
Filing Date:	06-	06-Aug-2003					
Title of Invention:		MICROFEATURE WORKPIECE PROCESSING SYSTEM FOR, E.G., SEMICONDUCTOR WAFER ANALYSIS					
First Named Inventor/Applicant Name:	Da	David A. Palsulich					
Filer:	Pai	Paul T Parker/Stephen Whelan					
Attorney Docket Number:	100	108298727US					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fee	s						
Description		Fee Code	Quantity	Amount	Sub-Total ir USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
rost-Allowance-and-rost-issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810